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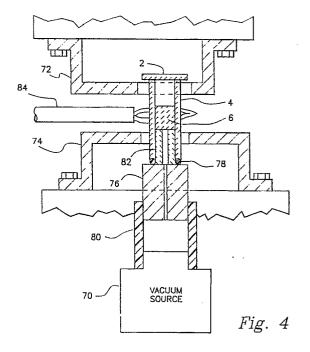
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(54) Semiconductor pressure sensor.

(57) An absolute pressure transducer includes a hollow glass tube (4) supporting across one end thereof a differential pressure responsive semiconductor plate (2) having piezoresistive elements diffused therein and an evacuated sealed chamber (8) within the tube exposed to the plate (2). Making the transducer (1) and providing the evacuated chamber (8) within the tube (4) adjacent to the plate (2) includes the steps of mounting the plate (2) across the end of the tube (4) to form a first fluid-tight seal therewith, inserting a loose glass plug (6) within the tube to define the chamber (8), exposing the interior of the tube (4) to a vacuum (70), concurrently heating the tube in the vicinity of the plug to allow the heated tube wall (10) to constrict around the plug in response to the internal vacuum and to fuse with the plug to form a second fluid-tight seal therewith and allowing the tube and plug to cool to trap the vacuum in the chamber.





EUROPEAN SEARCH REPORT

EP 89 10 6383

DOCUMENTS CONSIDERED TO BE RELEVA				Τ		
Category		th indication, where appropriate, evant passages		elevant o claim	CLASSIFICATION OF THE APPLICATION (Int. CI.5)	
Α	US-A-4 109 634 (KURTZ) * Column 2, lines 36-68; col		1 * 4-5	5	G 01 L 9/06	
Α	US-A-3 848 329 (IGARAS * Column 11, lines 22-68; co		e 3 *	7		
Α	DE-A-2 938 240 (HITACHI * Pages 7-8; fig. *	l) 	8-8)		
					TECHNICAL FIELDS SEARCHED (Int. Cl.5)	
					G 01 L	
The present search report has been drawn up for all claims						
	Place of search	Date of completion of s	earch		Examiner	
	The Hague 27 March 91			ZAFIROPOULOS N.		
X: particularly relevant if taken alone Y: particularly relevant if combined with another D: docu				ier patent document, but published on, or after filing date ument cited in the application ument cited for other reasons		
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